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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PRIORITY Application Serial No. 10/226,005
Confirmation No. unknown
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Inventor..... H. Daniel Dulman et al.
Assignee..... Micron Technology, Inc.
Group Art Unit..... unknown
Examiner unknown
Attorney's Docket No. MI22-2514
Customer No. 021567
Title: Methods Of Forming Aligned Structures With Radiation-Sensitive Material

PRELIMINARY AMENDMENT

To: Mail Stop PATENT APPLICATION
 Commissioner for Patents
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AMENDMENTS